

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	MAIL STOP AMENDMENT
Shigeyuki Akimoto et al.)	
Application No.: 10/556,916)	Group Art Unit: 2624
Filed: November 15, 2005)	Examiner: Vanchy Jr., Michael J.
For: OUTER SURFACE-INSPECTING)	Confirmation No.: 1621
METHOD, MASTER PATTERNS)	
USED THEREFOR, AND OUTER)	
SURFACE-INSPECTING)	
APPARATUS EQUIPPED WITH)	
SUCH A MASTER PATTERN)	

SUPPLEMENTAL AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 24, 2008 and supplemental to the amendment filed on October 27, 2008, please amend the above-identified patent application as follows: